

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/809,535	KELLEY ET AL.	
Examiner	Art Unit	
Kin-Chan Chen	1765	

SEARCHED					
Class	Subclass	Date	Examiner		
438 Î	689	7/7/2006	ксс		
438	693				
252	79.1				
112	79.5	7/1/2006	kcc		

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Epo, JPO, lerunt 18M-708, inventorseare	7/7/2006	ксс		
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